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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

APPLICANT(S): Helmut Fleischer et al ATTY: DOC. NO.: P06,0247
SERIAL NO.: 11/585,809
FILED: July 13, 2006
INVENTION: **METHOD, DEVICE, COMPUTER SYSTEM AND
COMPUTER PROGRAM PRODUCT FOR
CONTROLLING A MATERIAL FLOW**

MAIL STOP AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. §1.56, Applicants respectfully request that citation and examination of the following document be made during the course of examination of the above-referenced PCT application for United States Letters Patent.

EXPLANATION OF RELEVANCE

Reference AD is cited in the German Patent Office Action of November 25, 2004, a copy of which is enclosed.

Respectfully submitted,

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313 on January 16, 2007.


BRETT A. VALIQUET

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Sheet 1 of 1

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (use several sheets if necessary)					Docket No. P06,0247		Serial No. 10/585,809	
					Applicant Helmut Fleischer et al			
					Filing Date July 13, 2006		Group Art Unit Notassigned	
U.S. PATENT DOCUMENTS								
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate	
	AA							
	AB							
	AC							
	AD	6,305,548	10/23/01	Sato et al.				
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ1							
	AQ2							
	AS							
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AT							
	AU							
	AV							
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	AX							
	AY							
	AZ							
Examiner				Date Considered				
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								

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